



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideki KOMATSUDA et al.

Batch No.: D42

Allowed: March 13, 2001

Group Art Unit: 2882

Application No.: 09/396,582

Examiner: C. Church

Filed: September 15, 1999

Docket No.: 105203

For: EXPOSURE APPARATUS AND EXPOSURE METHOD USING SAME

5'12
7-19-01
C. Church

LETTER TO THE OFFICIAL DRAFTSPERSON

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Please substitute the attached 2 sheets of formal drawings depicting Figures 1 and 2
for the corresponding drawings filed with the application.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Mario A. Costantino
Registration No. 33,565

JAO:MAC/ccs

Date: April 12, 2001

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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